



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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E. Usillo  
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Applicant: WAYNE G. RENKEN  
Assignee: SENSARRAY CORPORATION  
Title: PROCESS CONDITION SENSING WAFER AND DATA ANALYSIS  
Application No.: 10/056,906 Filing Date: January 24, 2002  
Examiner: Unknown Group Art Unit: 3652  
Docket No.: M-12467 US

San Jose, California  
July 8, 2002

COMMISSIONER FOR PATENTS  
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT  
UNDER 37 CFR § 1.97(b)

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98, the documents listed on the accompanying form PTO-1449 are called to the attention of the Examiner for the above patent application. Copies of these documents are enclosed.

Citation of these documents shall not be construed as:

1. an admission that the documents are necessarily prior art with respect to the instant invention;
2. a representation that a search has been made; or
3. an admission that the information cited herein is, or is considered to be, material to patentability as defined in § 1.56(b).

EXPRESS MAIL LABEL NO:

EV029355494US

Respectfully submitted,

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